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BOX AF  
RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2625

00862.002866 (862.2866)

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
: Examiner: David A. Vanore  
SUSUMU GOTO )  
: Group Art Unit: 2881  
Appln. No.: 09/330,154 )  
: Filed: June 11, 1999 )  
: For: A PROJECTION APPARATUS FOR )  
: PROJECTING A PATTERN FORMED )  
: ON A MASK ONTO A SUBSTRATE )  
: AND A CONTROL METHOD FOR A )  
: PROJECTION APPARATUS )  
: (AS AMENDED) )  
: March 21, 2005  
: (Monday)

*Enter  
Per  
RCE  
5/12/05*

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

Introductory Comments

In response to the Official Action dated December 20, 2004, the Examiner is respectfully requested to amend the above-identified application as follows: